Title: METHOD OF COMPENSATING FOR ETCH EFFECTS

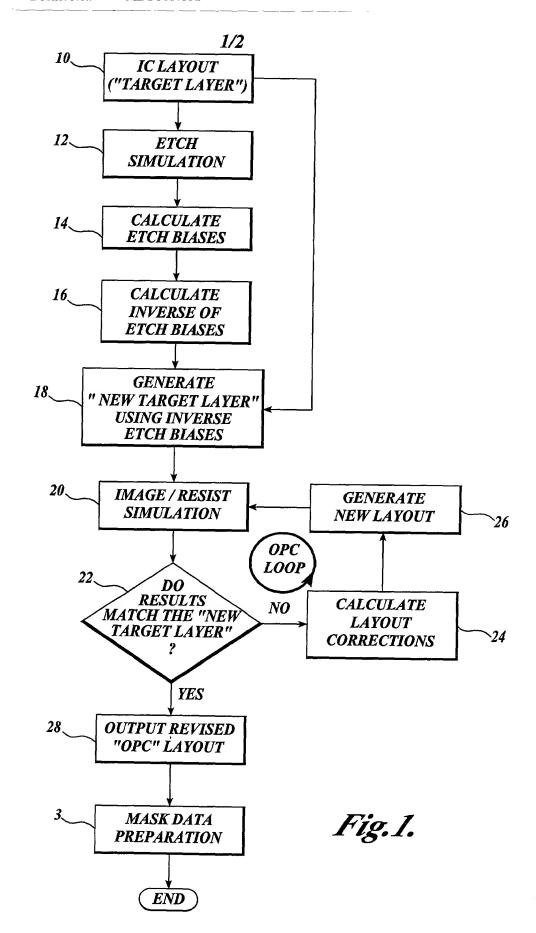
IN PHOTOLITHOGRAPHIC PROCESSING

Inventors:

Yuri Granik & Franklin M. Schellenberg

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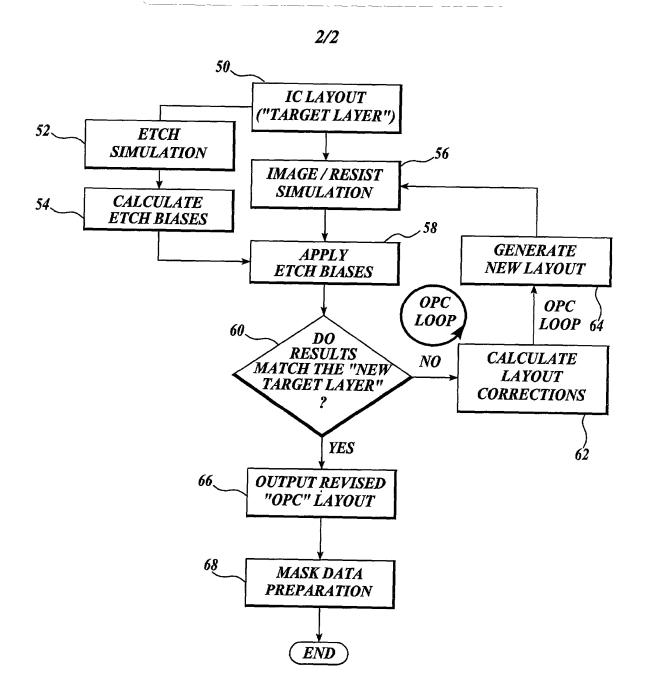


Fig. 2.